

Attorney Docket: 081468-0306001
Client Reference: P-0358.010-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 3252

Konstantin Nikolaevitch KOSHELEV et al.

Application No.: 10/664,065

Group Art Unit: 2881.

Filed: September 17, 2003

Examiner: Nikita WELLS

Title: Radiation Source, Lithographic Apparatus and Device Manufacturing Method

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR INITIALED INFORMATION DISCLOSURE STATEMENT

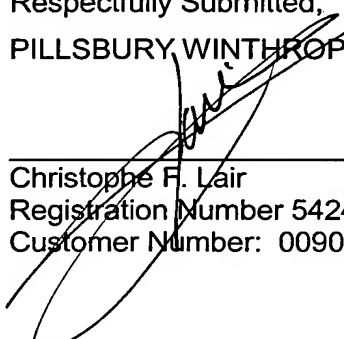
Applicant gratefully acknowledges receipt of the Notice of Allowance dated May 6, 2008.

In reviewing our files, Applicant noted that the references submitted on the Form PTO-1449 filed with the Information Disclosure Statement on September 17, 2003 and June 24, 2005 have not been considered. A copy of the aforementioned is attached for the Examiner's convenience.

Applicant respectfully requests that you return an initialed copy of the Information Disclosure Statement, indicating that the references were considered, as soon as possible.

Please contact the undersigned if you have any questions or concerns.

Respectfully Submitted,
PILLSBURY WINTHROP SHAW PITTMAN LLP



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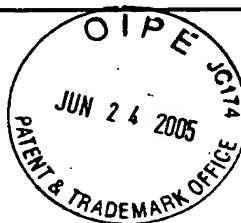
RECEIPT FROM PTO FOR INDICATED ITEMS

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Use this sheet when filing CPA or RCE

Appln. No: 10/664,065	Atty: Jean-Paul G. Hoffman/La Toya M. Jackson
First Inventor: KONSTANTIN NIKOLAEVITCH KOSHELEV	Date: June 24, 2005
Title: RADIATION SOURCE, LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD	Attorney Docket No: 081468-0306001

ENCLOSED:

☒ Information Disclosure Statement☒ PTO/SB/08aCURRENT DUE DATE: